

Notice of References Cited	Application/Control No. 10/659,286		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Temesghen Ghebretinsae		Art Unit 2611	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,392,315 A	02-1995	Laud, Timothy G.	375/232
*	B	US-6,563,868 B1	05-2003	Zhang et al.	375/232
*	C	US-6,483,872 B2	11-2002	Nguyen, Thi N.	375/231
*	D	US-2005/0053127 A1	03-2005	Shiue et al.	375/232
*	E	US-7,127,019 B2	10-2006	Koslov, Joshua L.	375/371
*	F	US-5,675,394	10-1997	Choi, Young-Bae	348/614
*	G	US-5,777,910 A	07-1998	Lu, Cheng-Youn	708/323
*	H	US-6,385,239 B1	05-2002	Okamoto et al.	375/232
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.